



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 14, 2026

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

LG811645420

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.43 - 7.45 X 4.59 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.56 CARAT

H

VS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

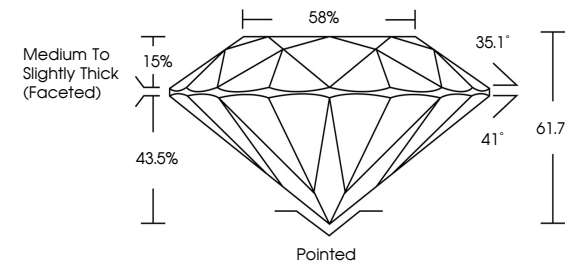
EXCELLENT

NONE

IGI LG811645420

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

58%

35.1°

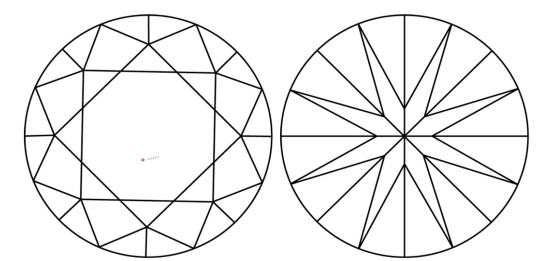
41°

61.7%

43.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

Sample Image Used



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www.igi.org

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